

**Amendments to the Specification:**

Please replace the last full paragraph on page 4, starting at line 25, with the following paragraph:

Substrate 1 can be grounded or connected to the ungrounded output of a voltage source ~~such as that shown in Fig. 1~~. The voltage between substrate and a plasma formed by the electric discharge is preferably between one volt (V) and 3000 V, more preferably, between 100 V and 1000 V. Pulsed DC voltages with a pulse frequency between ten kHz and 100 kHz can also be considered as DC voltages. When low-frequency AC voltages are used, the frequency is preferably between 50 Hz and 60 Hz, and with intermediate-frequency AC voltages preferably between ten kHz and 100 kHz. High-frequency AC voltages preferably have frequencies between one MHz and 50 MHz. Instead of, or in addition to, supplying power with a voltage source, it can also be supplied by microwaves. The microwave frequencies are preferably in the gigahertz (GHz) range.

*H1*